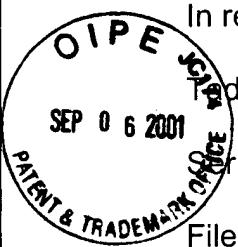


#4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re the application of:

Kazuhiko OHMI et al

SEP 06 2001

Serial Number: 09/864,376

Filed: May 25, 2001

For: PLASMA PROCESSING APPARATUS AND
PLASMA PROCESSING METHODATTN: Application Branch

Confirmation No.: 1605

Atty. Docket No.: 107176-00007

RECEIVED
SEP 25 2001
TC 1700

REQUEST FOR CORRECTED FILING RECEIPTHonorable Commissioner for Patents
Washington, D.C. 20231

September 6, 2001

Sir:

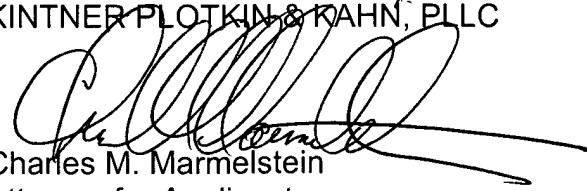
Please supply the undersigned attorney with a corrected filing receipt of the above-identified application.

In reviewing the Official Filing Receipt, we noted an error in the second inventor's name. The second inventor's name should read -- Kazuhide INO --. In support of this request, enclosed is a copy of Declaration and Power of Attorney, along with a copy of the filing receipt with the correction highlighted in yellow.

In the event any fees are due with respect to this paper, please charge our Deposit Account No. 01-2300.

Respectfully submitted,

AREN'T FOX KINTNER PLOTKIN & KAHN, PLLC



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CMM:mmg

Enclosures: Declaration and Power of Attorney (copy); Official Filing Receipt (copy)



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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/864,376	05/25/2001	1763	0.00	107176-00007	4	8	2

CONFIRMATION NO. 1605

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ARENT FOX KINTNER PLOTKIN & KAHN, PLLC
Suite 600
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Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Takahiro Arakawa, Kyoto-shi, JAPAN;

Domestic Priority data as claimed by applicant

Foreign Applications

JAPAN 2000-156535 05/26/2000

If Required, Foreign Filing License Granted 07/26/2001

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

REVIEWED IN _____
DOCKETING BY LM/ED
DATE 7-31-01

Title

Plasma processing apparatus and plasma processing method

Preliminary Class

Data entry by : ASRAT, FANAYE

Team : OIPE

Date: 07/26/2001



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CONFIRMATION NO. 1605

SERIAL NUMBER 09/864,376	FILING DATE 05/25/2001 RULE	CLASS 156	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 107176-00007
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APPLICANTS

Tadahiro Ohmi, Sendai-shi, JAPAN;
Kazuhide Ino, Kyoto-shi, JAPAN;
Takahiro Arakawa, Kyoto-shi, JAPAN;

**** CONTINUING DATA *******

**** FOREIGN APPLICATIONS *******

JAPAN 2000-156535 05/26/2000

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Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance
Verified and Acknowledged	<i>May 26/02</i> Examiner's Signature Initials
STATE OR COUNTRY	STATE OR COUNTRY JAPAN
SHEETS DRAWING	SHEETS DRAWING 4
TOTAL CLAIMS	TOTAL CLAIMS 8
INDEPENDENT CLAIMS	INDEPENDENT CLAIMS 2

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TITLE

Plasma processing apparatus and plasma processing method

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